



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Group Art Unit:

Application No.: 10/613,081

Examiner:

Filed: July 7, 2003

Docket No.: 116462

For: COMPOSITION, ORGANIC CONDUCTIVE LAYER INCLUDING COMPOSITION, METHOD FOR MANUFACTURING ORGANIC CONDUCTIVE LAYERS, ORGANIC EL ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING ORGANIC EL ELEMENTS, SEMICONDUCTOR ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING SEMICONDUCTOR ELEMENTS, ELECTRONIC DEVICE, AND ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application.

☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

☒ 4. U.S. Patent No. 6,878,312 B1 is the English-language counterpart of Korean Patent Application No. 2001-0043918, of which WO 00/592676 is also a counterpart.

Respectfully submitted,



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JAO:SWA/jam

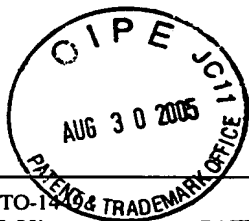
Date: August 30, 2005

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**DEPOSIT ACCOUNT USE
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Sheet 1 of 1

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| Form PTO-1414 (REV. 8-83) | | US Dept. of Commerce PATENT & TRADEMARK OFFICE | | ATTY DOCKET NO. 116462 | | APPLICATION NO. 10/613,081 | |
| INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | | | APPLICANT(S) Shunichi SEKI et al. | | | |
| | | | | FILING DATE July 7, 2003 | | GROUP 2811 | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | |
| | 1 | 6,083,635 | 07/04/2000 | JONAS et al. | | | |
| | 2 | 6,878,312 B1 | 04/12/2005 | KANBE et al. | | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUB CLASS | |
| | 3 | KR 2001-0043918 | 05/25/2001 | KOREA | | | |
| | 4 | WO 00/59267 | 10/05/2000 | JAPAN | | | |
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| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.) | | | | | | | |
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| Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | | | |

Date: August 30, 2005